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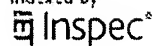
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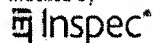
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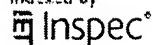
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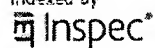
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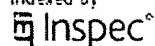
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- ☐ 1. **A pneumatically actuated full in-channel microvalve with MOSFET-like full channel networks**  
 Takao, H.; Ishida, M.; Sawada, K.;  
[Microelectromechanical Systems, Journal of](#)  
 Volume 11, Issue 5, Oct. 2002 Page(s):421 - 426  
 Digital Object Identifier 10.1109/JMEMS.2002.803414  
[AbstractPlus](#) | [References](#) | Full Text: [PDF](#)(299 KB) IEEE JNL  
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- ☐ 2. **Micromachined silicon microvalve**  
 Ohnstein, T.; Fukiura, T.; Ridley, J.; Bonne, U.;  
[Micro Electro Mechanical Systems, 1990. 'Proceedings, An Investigation of Micro Sensors, Actuators, Machines and Robots', IEEE](#)  
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- ☐ 3. **A novel bulk micromachined electrostatic microvalve with a curved-comb applicable for a pneumatic tactile display**  
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[Microelectromechanical Systems, Journal of](#)  
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- ☐ 4. **Low-cost technology for high-density microvalve arrays using polydimethyl (PDMS)**  
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- ┐ 6. **Design, fabrication, and testing of a bistable electromagnetically actuated**  
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- ┐ 7. **A hydrogel-actuated smart microvalve with a porous diffusion barrier bar**  
**active flow control**  
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- ┐ 8. **A multi-channel micro valve for micro pneumatic artificial muscle**  
Yong Kwun Lee; Shimoyama, I.;  
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20-24 Jan. 2002 Page(s):702 - 705  
Digital Object Identifier 10.1109/MEMSYS.2002.984367  
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- ┐ 9. **Microvalve with ultra-low leakage**  
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- ┐ 10. **Normally close microvalve and micropump fabricated on a silicon wafer**  
Esashi, M.; Shoji, S.; Nakano, A.;  
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- ┐ 11. **Three-way microvalve for blood flow control in medical micro total analy**  
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Ohori, T.; Shoji, S.; Miura, K.; Yotumoto, A.;  
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16. **A normally-closed, bimetallically actuated 3-way microvalve for pneumatic applications**  
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18. **Bistable microvalve with pneumatically coupled membranes**  
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20. **A nested electrostatically-actuated microvalve for an integrated microflo**  
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21. **Bubble engineering for biomedical valving applications**  
Ki, Y.-S.L.; Kharouf, M.; Van Lintel, H.T.G.; Haller, M.; Renaud, P.;  
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Digital Object Identifier 10.1109/5.9669  
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23. **Thin film shape memory alloy microactuators**  
Krulvitch, P.; Lee, A.P.; Ramsey, P.B.; Trevino, J.C.; Hamilton, J.; Northrup, I  
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24. **Stress analysis of silicon membranes with electroplated permalloy films scattering**  
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25. **Design of reconfigurable composite microsystems based on hardware/s principles**  
Zhang, T.; Chakrabarty, K.; Fair, R.B.;  
[Computer-Aided Design of Integrated Circuits and Systems, IEEE Transaction](#)  
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 Etoh, S.; Fujimura, T.; Hattori, R.; Kuroki, Y.;  
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- ☐ 27. **Modulation of drug delivery rate by hydrogel-incorporating MEMS device**  
 Yuandong Gu; Baldi, A.; Ziaie, B.; Siegel, R.A.;  
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- ☐ 28. **Electronic fountain pen - a highly integrated stand-alone microdosage sy**  
 Waibel, G.; Kohnle, J.; Cernosa, R.; Storz, M.; Schmitt, M.; Ernst, H.; Sandmai R.; Strobel, T.;  
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- ☐ 29. **A shuttered probe with in-line flowmeters for chronic in-vivo drug deliver**  
 Papageorgiou, D.; Bledsoe, S.C.; Gulari, M.; Hetke, J.F.; Anderson, D.J.; Wise  
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- ☐ 30. **A high density microchannel network with integrated valves and photodi**  
 Baechi, D.; Dual, J.; Buser, R.;

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Gaugel, T.; Bechtel, S.; Neumann-Rodekirch, J.;  
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32. **An intelligent micro-fluidic system for drug delivery**  
Tay, F.E.H.; Choong, W.O.; Liu, H.; Xu, G.L.;  
Industrial Technology 2000. Proceedings of IEEE International Conference on  
Volume 2, 19-22 Jan. 2000 Page(s):70 - 75 vol.1  
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33. **Paraffin actuated surface micromachined valves**  
Carlen, E.T.; Mastrangelo, C.H.;  
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23-27 Jan. 2000 Page(s):381 - 385  
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34. **Miniature one-shot valve**  
Guerin, L.J.; Dubochet, O.; Zeberli, J.-F.; Clot, P.; Renaud, P.;  
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35. **A proportional microvalve using a bi-stable magnetic actuator**  
Shinozawa, Y.; Abe, T.; Kondo, T.;  
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26-30 Jan. 1997 Page(s):233 - 237  
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36. **The selfpriming VAMP**  
Stehr, M.; Gruhler, H.; Straatmann, H.; Messner, S.; Sandmaier, H.; Zengerle, R.;  
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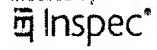
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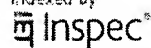
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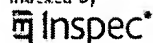
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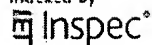
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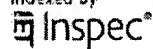
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IEE JNL IEE Journal or Magazine

IEEE CNF IEEE Conference Proceeding

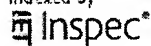
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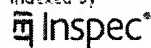
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